

2811

500.39240X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: INOUE et al.
Serial No.: 09/698,185
Filed: October 30, 2000
For: SEMICONDUCTOR DEVICE AND METHOD FOR
MANUFACTURING THE SAME
Group: 2811
Examiner: L. Thai

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AMENDMENT

Assistant Commissioner
for Patents
Washington, D.C. 20231

January 14, 2002

Sir:

In response to the Restriction Requirement dated
December 12, 2001, please amend the above-identified
application as follows:

In the Claims:

Please cancel claims 7-14 without prejudice or disclaimer
of the subject matter thereof.

Please amend claim 2 as follows:

2. (Amended) A semiconductor apparatus according to
Claim 1, wherein said wiring is formed on one of said opposite
inclined portions which is smaller in inclination angle than
the other of said opposite inclined portions of said
electrically insulating layer.

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